



AS01MC.047AUS

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Huotari
App. No. : 10/601,037
Filed : June 19, 2003
For : METHOD TO FABRICATE
DUAL METAL CMOS DEVICES
Examiner : Christy Novacek
Art Unit : 2822

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

November 4, 2004

(Date)

Andrew N. Merickel, Reg. No. 53,317

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION**Mail Stop AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Final Office Action filed on August 4, 2004. As they are believed to place the application in condition for allowance and do not require extensive consideration, Applicants respectfully request entry of the following amendments and consideration of the subsequent remarks.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 7 of this paper.